

**RECEIVED  
CENTRAL FAX CENTER**

Confirmation No. 6408

JUL 03 2007

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Meunier-Beillard <i>et al.</i>	Examiner:	Khiem Nguyen
Serial No.:	10/550,853	Group Art Unit:	2823
Filed:	September 22, 2005	Docket No.:	NL030357 US1
Title:	METHOD OF EPITAXIAL DEPOSITION OF AN N-DOPED SILICON LAYER		

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being transmitted via facsimile-Formal Entry, to the attention of the Examiner at Commissioner for Patents, MAIL STOP AMENDMENT, P.O. Box 1450, Alexandria, VA 22313-1450, on July 3, 2007.

By: Kelly Davis

Kelly Davis

**Facsimile No.: 571 273-8300**

Customer No.

**65913**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated April 3, 2007, please reconsider the application in view of the following amendments and remarks.

A complete listing of the claims, to include any amendments presented therein, begins on page 2 of this paper.

Remarks/Arguments follow on page 5.

**Authorization is provided to charge/credit Deposit Account 50-0996 (NXPS.265PA) any requisite fees/overages to enter this paper.**